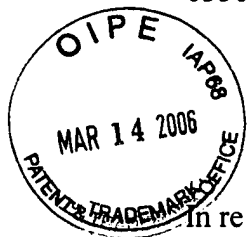


TFW
1762

03500.014241

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

NOBUHIRO ITO

Application No.: 09/505,627

Filed: February 16, 2000

For: MANUFACTURING METHOD OF)
ELECTRON BEAM APPARATUS :
AND SPACER, AND ELECTRON)
BEAM APPARATUS :

Examiner: B. Talbot

Group Art Unit: 1762

March 13, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

A. Introductory Comments

In response to the Office Action dated December 14, 2005, please amend
the application as follows and consider the following remarks.